

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 98,162-B)

In re Application of:)

DeGendt, et al.)

Serial No.: 09/207,546)

Filed: December 8, 1998)

For: METHOD FOR REMOVING ORGANIC)
CONTAMINANTS FROM A)
A SEMICONDUCTOR SURFACE)

Group Art Unit: 1746

Examiner: Ahmed

Commissioner for Patents
Washington, D.C. 20231

OFFICIAL

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AUG 24 2001
GROUP 1700

PRELIMINARY AMENDMENT

Dear Sir:

In response to the outstanding Office Action mailed March 22, 2001, please enter the following remarks and amendments in the above-referenced patent application.

IN THE CLAIMS

Please amend claim 27 as follows. A marked up version of the amended claim, to show all the changes, is attached hereto on pages separate from the amendment in accordance with 37 CFR 1.121(c)(1)(ii).

27. (Amended) A method for removing organic contaminants from a substrate, the organic contaminants resulting from a previous lithographic step, the method comprising the steps of:

holding said substrate in a tank; and

McDONNELL BOEHNEN
HULBERT & BERGHOFF
300 South Wacker Drive, Suite 3200
Chicago, Illinois 60606
(312) 913-0001

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8-29-01

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